

Substitute for form 1449/PTO				<i>Complete if Known</i>	
				Application Number	10/568,288-Conf. #3490
				Filing Date	February 6, 2007
				First Named Inventor	Juergen Hausselt
				Art Unit	1724
				Examiner Name	J. Berman
Sheet	1	of	1	Attorney Docket Number	31775-226082

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear <sup>6</sup> T

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			
	CA	Heavens, S.N., Electrophoretic Deposition as a Processing Route for Ceramics in Binner, J. (Ed.), Advanced Ceramic Processing and Technology, Vol. 1, Noyes Publ., Park Ridge, N.J. U.S., 1990			
	CB	Both, H. von; Hausselt, J.: <i>1st Intern. Conf. on Electrophoretic Deposition</i> , Banff, Canada, 2002			
	CC	Nitzsche, R. & Simon, F.: <i>TECHNISCHES MESSEN</i> [Technical Measuring] Volume 64, pages 106-113, 1997			

Examiner Signature	/Jason Berman/	Date Considered	12/13/2010
--------------------	----------------	-----------------	------------

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. \* CITE NO.: Those application(s) which are marked with an single asterisk (\*) next to the Cite No. are not supplied (under 37 CFR 1.98(a)(2)(iii)) because that application was filed after June 30, 2003 or is available in the IFW. <sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /J.B./